

Notice of Allowability	Application No.	Applicant(s)		
	09/683,536	HSIEH ET AL.	HSIEH ET AL.	
	Examiner	Art Unit		
	Ren L. Yan	2854		
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate commits (GHTS). This application is a	n this application. If not incluunication will be mailed in du	ided ie course. THIS	
1. This communication is responsive to an RCE filed on 1/9/2	<u>0006</u> .			
2. The allowed claim(s) is/are 1,3-10 and 13-23.				
3. ☐ Acknowledgment is made of a claim for foreign priority una) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" on the other priority documents have included below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. ☐ A SUBSTITUTE OATH OR DECLARATION must be submited in Patent Application (PTO-152) which give 5. ☐ CORRECTED DRAWINGS (as "replacement sheets") must including changes required by the Notice of Draftspers 1) ☐ hereto or 2) ☐ to Paper No./Mail Date	been received. been received in Application cuments have been received of this communication to file ENT of this application. itted. Note the attached EXA es reason(s) why the oath of the submitted. on's Patent Drawing Review	on No d in this national stage applicate a reply complying with the real stage and the reply complying with the replaced and the replaced area of the complete of the	equirements	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.			he back) of	
each sheet. Replacement sheet(s) should be labeled as such in the	ne header according to 37 CF	R 1.121(d).	no baok, or	
6. DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT INFORMATION ABOUT THE PROPERTY OF THE P	SIT OF BIOLOGICAL MATE FOR THE DEPOSIT OF BIO	ERIAL must be submitted DLOGICAL MATERIAL.	. Note the	
Attachment(s) 1. Notice of References Cited (PTO-892)	5. ☐ Notice of In	formal Patent Application (P	TO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview S	6. Interview Summary (PTO-413), Paper No./Mail Date 7. Examiner's Amendment/Comment		
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08				
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's	8. X Examiner's Statement of Reasons for Allowance		
	9.	9. Other		

DETAILED ACTION

The following is an examiner's statement of reasons for allowance:

The overall combination of structure of a document imaging background member as recited in claim 1 including particularly a substrate having a dark color and wherein at least of portion of a surface of the substrate is coated with a fluorescent coating which permits the dark color of the substrate to appear when the fluorescent coating is not exposed to a light source, and the fluorescent coating fluoresces or emits light in response to exposure to the light source so as to appear white, is not taught nor suggested by the prior art of record. Independent claims 10 and 21 directed to an imaging device that contains a substrate having the same structural limitations as discussed above are also allowed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ren L. Yan whose telephone number is 571-272-2173. The examiner can normally be reached on 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Andrew Hirshfeld can be reached on 571-272-2168. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Ren L Yan

Primary Examiner

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Ren Yan March 8, 2006